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APPLICANTS

Yuji Imai, Saitama, JAPAN;

** CONTINUING DATA *****
 This application is a DIV of 09/839,202 04/23/2001 PAT 6,737,207 HN

** FOREIGN APPLICATIONS ***** HN
 JAPAN 2000-124506 04/25/2000

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Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance HW Examiner's Signature Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWING 10	TOTAL CLAIMS 12	INDEPENDENT CLAIMS 2
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ADDRESS
 25944
 OLIFF & BERRIDGE, PLC
 P.O. BOX 19928
 ALEXANDRIA, VA
 22320

TITLE
 Method for evaluating lithography system, method for adjusting substrate-processing apparatus, lithography system, and exposure apparatus

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